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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kenji NISHI et al.**

Group Art Unit: **2851**

Serial No.: **10/718,728**

Examiner: **Hung Henry V. Nguyen**

Filed: **November 24, 2003**

Confirmation No.: **1835**

For: **AN EXPOSURE APPARTUS, EXPOSURE METHOD USING THE
SAME, AND METHOD OF MANUFACTURE OF CIRCUIT DEVICE**

Attorney Docket Number: **991185B**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: January 14, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated October 20, 2004, for one month from December 20, 2004 to January 20, 2005.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension for a large entity. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

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